

PATENT APPLICATION
Docket No.: 4591-366
Client Ref. No.: IC12242-US

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Jeong-Min CHOI et al.

Serial No.:	10/750,983	Examiner:	Pert, Evan T.
Filed:	January 2, 2004	Group Art Unit:	2826
Confirmation No.:	5470		
For:	SEMICONDUCTOR DEVICE HAVING SILICIDE FORMED WITH BLOCKING INSULATION LAYER		

Mail Stop Issue Fee
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

OK TO ENTER: /E.P./

08/12/2008

AMENDMENT AFTER ALLOWANCE UNDER 37 CFR § 312

Responsive to the Notice of Allowance dated April 3, 2008, please amend the application as follows.

Amendments to the Claims begin on page 2 of this paper.

Remarks/Arguments begin on page 5 of this paper.